

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of: SINGH et al.

Appln No.: 10/082,010

Examiner: Umez Eronini, Lynette T.

Date Filed: February 22, 2002

Group: 1765

For: SLURRY AND METHOD FOR CHEMICAL MECHANICAL POLISHING
OF METAL STRUCTURES INCLUDING REFRACTORY METAL
BASED BARRIER LAYERS

REPLY TO NON-FINAL OFFICE ACTION

Mail Stop Amendment

Commissioner for Patents

P. O. Box 1450

Alexandria, VA 22313-1450

Sir:

This Reply is responsive to the Non-Final Office Action mailed September 28, 2006.

Amendments to the Claims are contained in the complete claim listing which appears
on pages 2-7 of this document.

Remarks/arguments begin on page 8 of this document.